



Attorney Docket No. 740756-2681

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	
Akiharu MIYANAGA et al.	)	Group Art Unit: 1762
Application No. 10/728,987	)	
Filed: December 8, 2003	)	Examiner: W. Markham
For: PULSED PLASMA CVD METHOD	)	Confirmation No.: 1100
FOR FORMING A FILM	)	
(AS AMENDED)	)	April 11, 2005

**AMENDMENT**

Mail Stop **RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 9, 2004, and the Request for Continued Examination filed concurrently, please amend the above identified application as follows.

**Amendments to the Specification** begin on page 2 of this paper

**Amendments to the Claims** begin on page 5 of this paper.

**Remarks** begin on page 11 of this paper.